

PEFP status



EPICS Collaboration meeting
Dec 8-10, 2004 RICOTTI, Tokai, JAPAN



Pohang Accelerator Laboratory
POSTECH

Outline



I. PEFP

- Goal
- Plan, Schedule
- Status of Accelerator Development
- Project progress

II. 20Mev Control System

- History
- Development Status of Sub Control System
 - .Vacuum,RF,Event,Beam Monitor, PS ,Utility

Proton Engineering Frontier Project



**Collaboration with
KAERI , PAL,KAPRA,KIGAM,KAIST.**

**Under construction for 20Mev Com
missioning in KAERI-Deajeon**

**Final Site will be selected by end of this
year.**

KAERI – Korea Atomic Energy Research Institute

KAPRA – Korea Accelerator & Plasma Research Association

KIGAM – Korea Institute of Geoscience & Mineral Resources

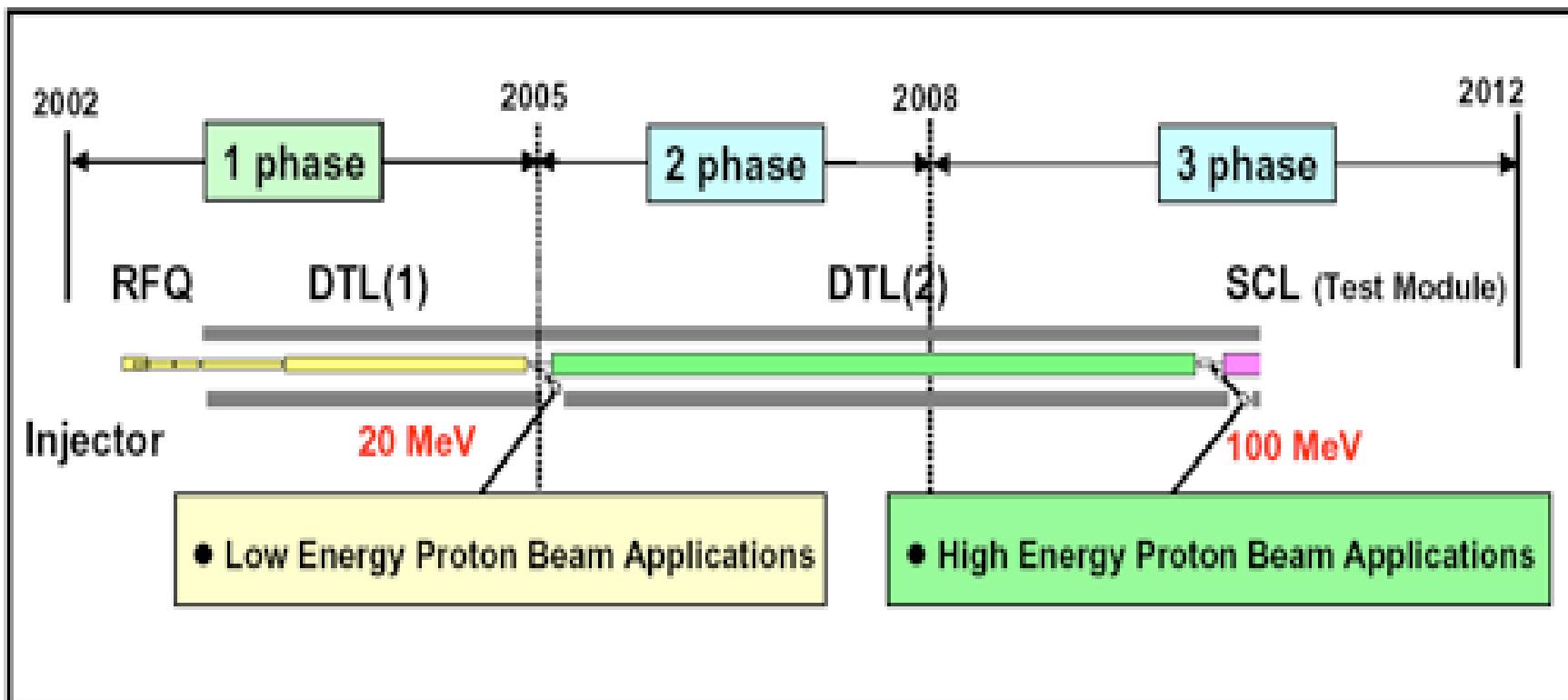
KAIST – Korea Advanced Institute Science and Technolgy

Project Goal

- Project Name : Proton Engineering Frontier Project
- Project Goals :
 - 1st : Developing & constructing a proton linear accelerator (100MeV, 20mA)
 - 2nd : Developing technologies of proton beam utilizations & accelerator applications
 - 3rd : Promoting industrial applications of developed technologies
- Project Period : 2002.7 – 2012.7 (10 years)
- Project Cost : 128.6 B Won (107M\$)
 - Special Conditions : Land, site & supporting facilities will be provided by a host institution or a local government.

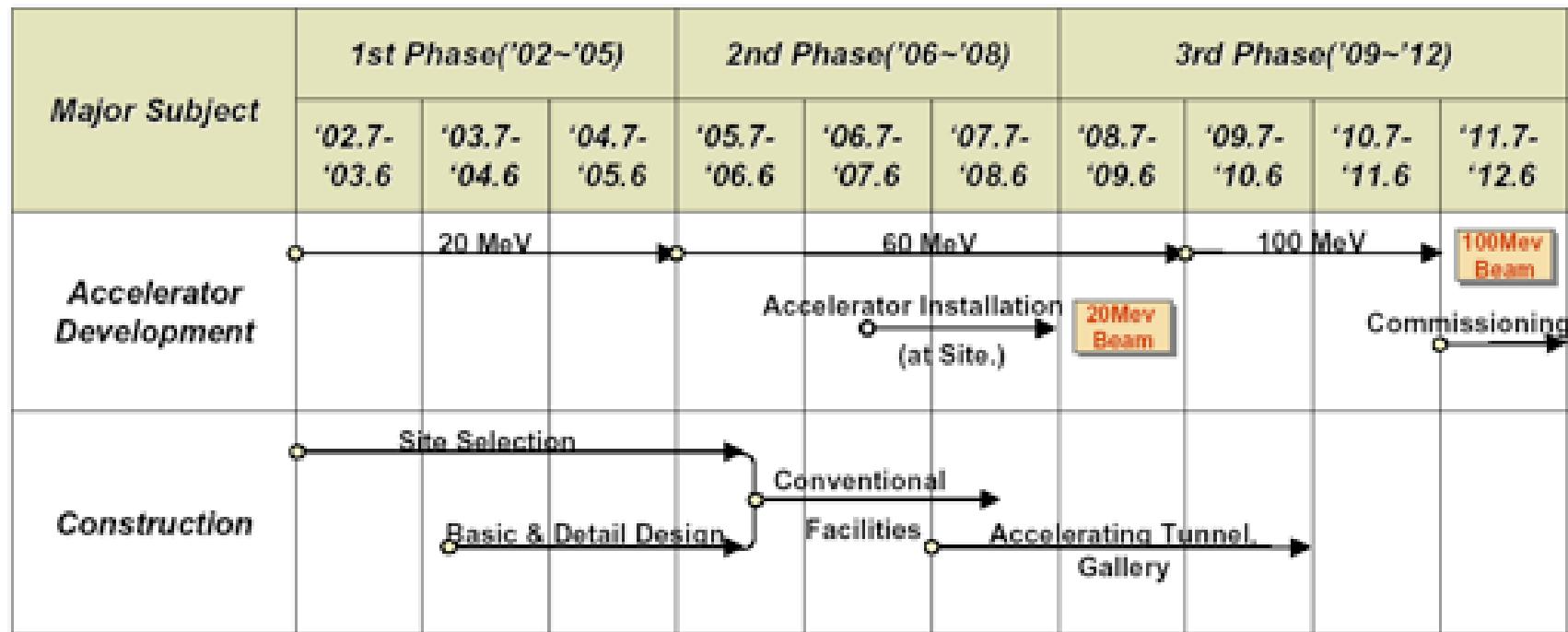
Refer to Slide materials(Page 3~8)presented at ICFA-HB 2004
October 20.2004 , Beansheim ,Germany
“Status and progress of the PEFP Project”
By Byung-Ho Choi & PEFP Team

Plan of PEFP(100MeV Linac & Utilization)



- PEFP is organized into 3 phases.
- Its accelerator composes of an Injector, RFQ, DTL(I), DTL(II) and a test module of SCL
- It has 2 beam extraction system ; a low energy proton beam extraction of 20MeV, a high energy beam of 100MeV
- Extracted proton beams will be used in various fields of beam utilizations & applications.
- We open a future extension plan over 100MeV

Project Schedule



- Revised major milestones of the accelerator development & construction.
- In the 1st Phase, 20MeV accelerator will be constructed.
- After completion of the 20MeV accelerator in KAERI site in the 1st phase, it will be moved to new site and commissioning to supply 20MeV proton beam.
- 20MeV beam will be provided by Jun. 2008, 100MeV Beam by Jun. 2011

Basic Accelerator Parameters

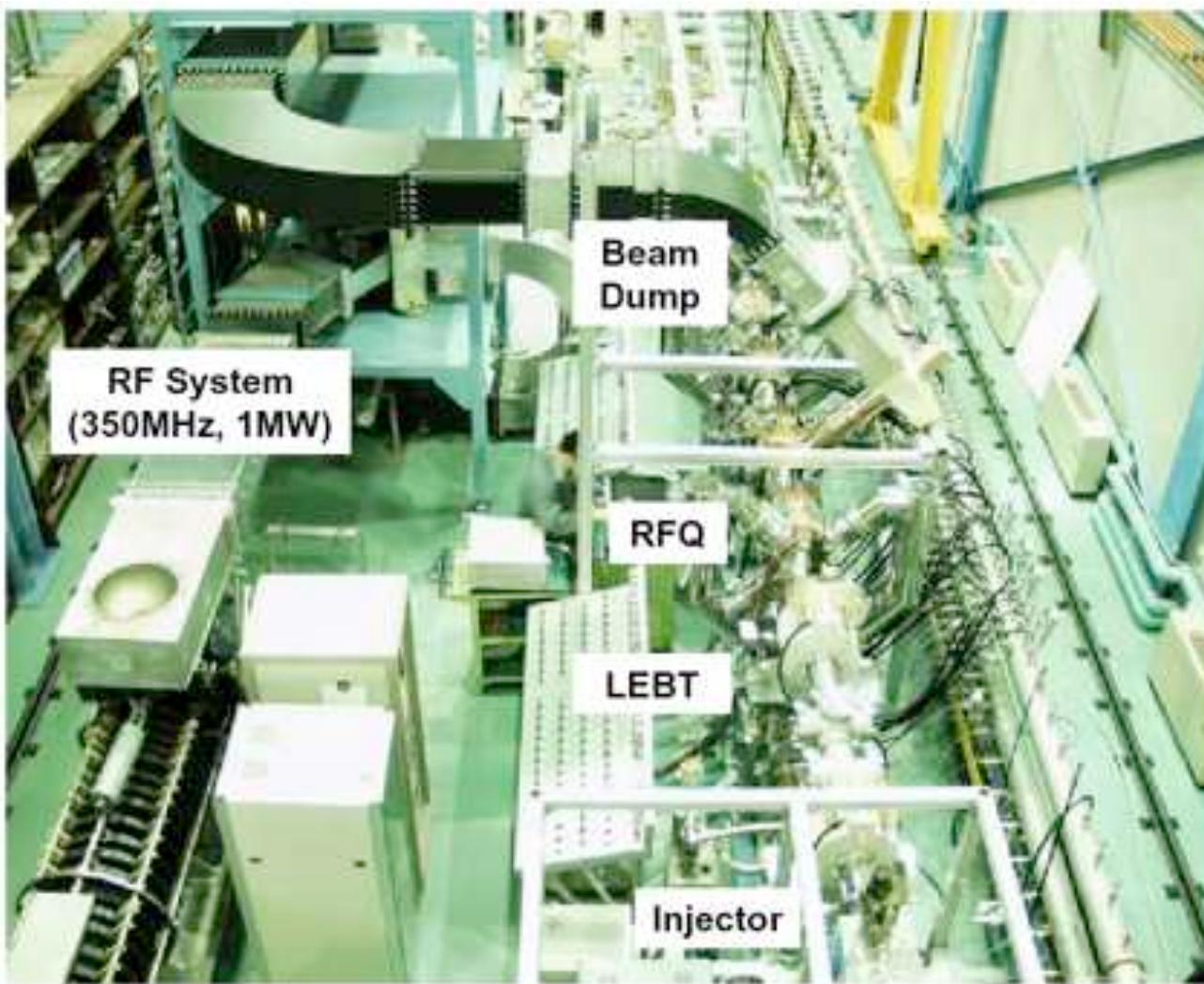


- Particle : Proton
- Beam Energy : 100MeV
- Operational Mode : Pulsed
- Max. Peak Current : 20 mA
- Repetition Rate : 15 Hz for Commissioning to User
(120Hz in Accelerator Design)
- Pulse Width : < 1 ms for Commissioning to User
(< 2 ms in Accelerator Design)
- Max. Beam Duty : 1.5% for Commissioning to User
(24% in Accelerator Design)
- Accelerator Structures : Linear Acc.

1st Option : Injector - 3MeV RFQ - 100MeV DTL

2nd Option : Injector - 3MeV RFQ - 60MeV DTL - 100MeV SCL (under study)

Status of Accelerator Development(Nov. 2002)



- Injector, LEBT, RFQ & RF System have been developed.
- 50keV injector & LEBT were tested and operated
- RF system of RFQ was tested
- RFQ is under the beam test
- DTL is under fabrication

Project Progress



□ Total progress chart of 10 years ('02.7-'12.7)

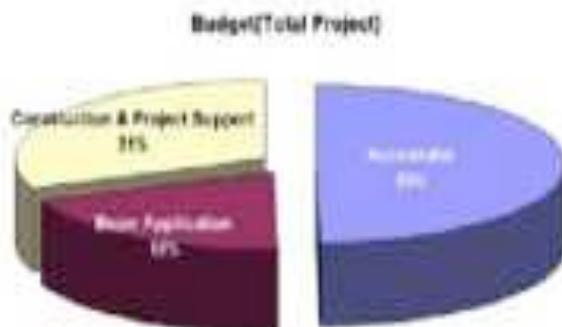
► Progress (by Aug 2004)

achieved : 14.8%

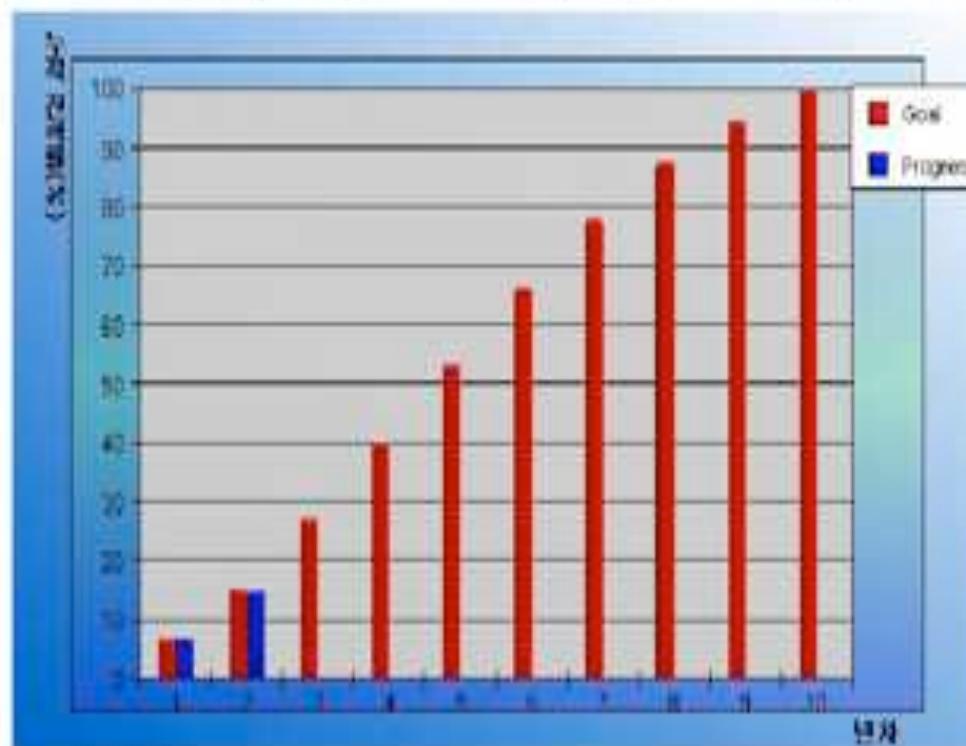
planned : 15.2%

(0.4% delayed)

► Budget [128,567 M W]



Note) not include a budget of land, site & supporting facilities by a host



Year	1	2	3	4	5	6	7	8	9	10
Goal (sum)	6.9	15.2	27.1	40.2	53.2	66.2	77.9	87.6	94.6	100
Achieved (sum)	6.9	14.8								

Control System for 20MeV Commissioning



- Scheduled to 20 MeV commissioning in April 2005 at KAERI, Deajeon
- Development of Control System to satisfy this mission has been executed at PAL in 3 Phases for last 3 years.

➤ First Phase Development(2002.7~2003.6)

- . Control System Architecture
- . Control ToolKit Choice (EPICS)
- . Vacuum Control System

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➤ Second Phase Development(2003.7~2004.6)

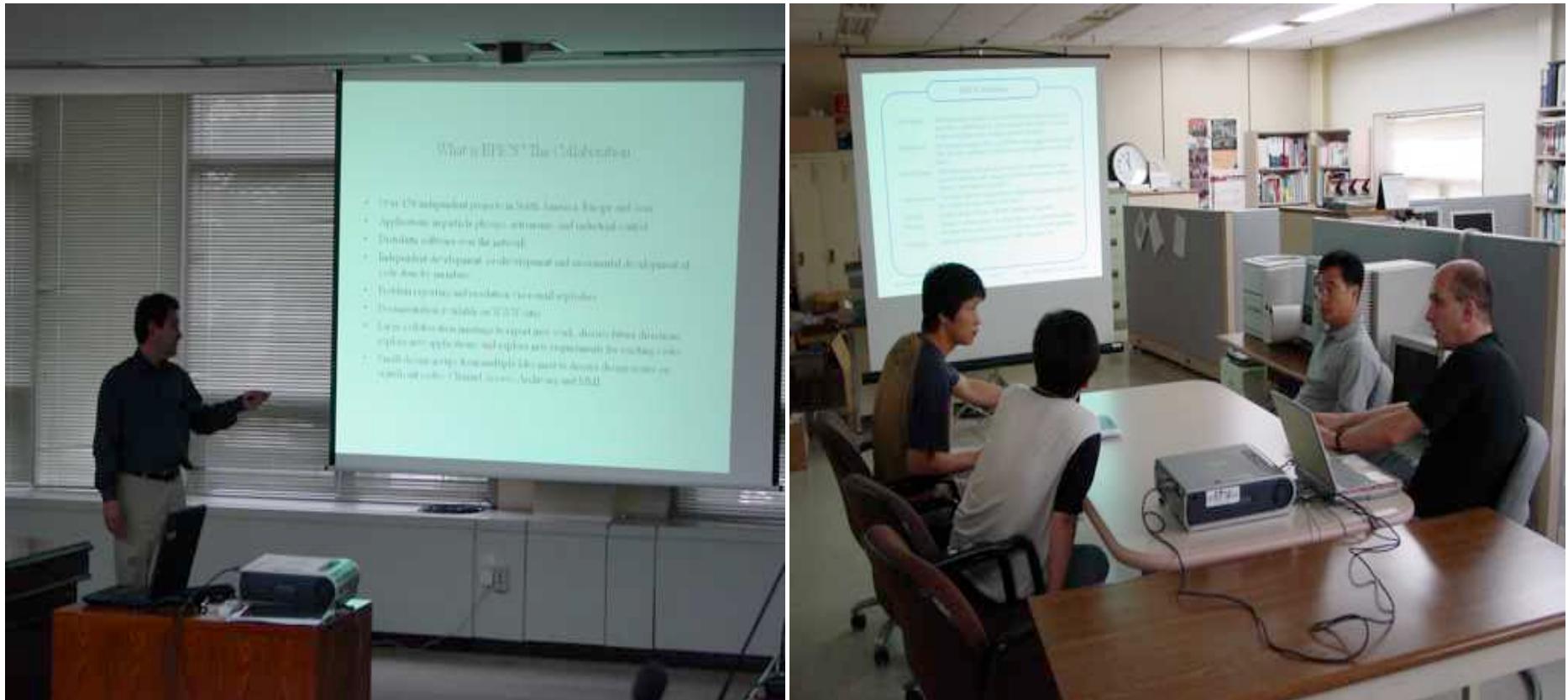
- . RF Control System
- . Event System for Timing Control

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➤ Third Phase Development (2004.7~2005.6)

- . Beam Monitor Control
- . Power Supply Control
- . Cooling Water Monitoring
- . Intergration and Commissioning

EPICS Expert Invitation for Review



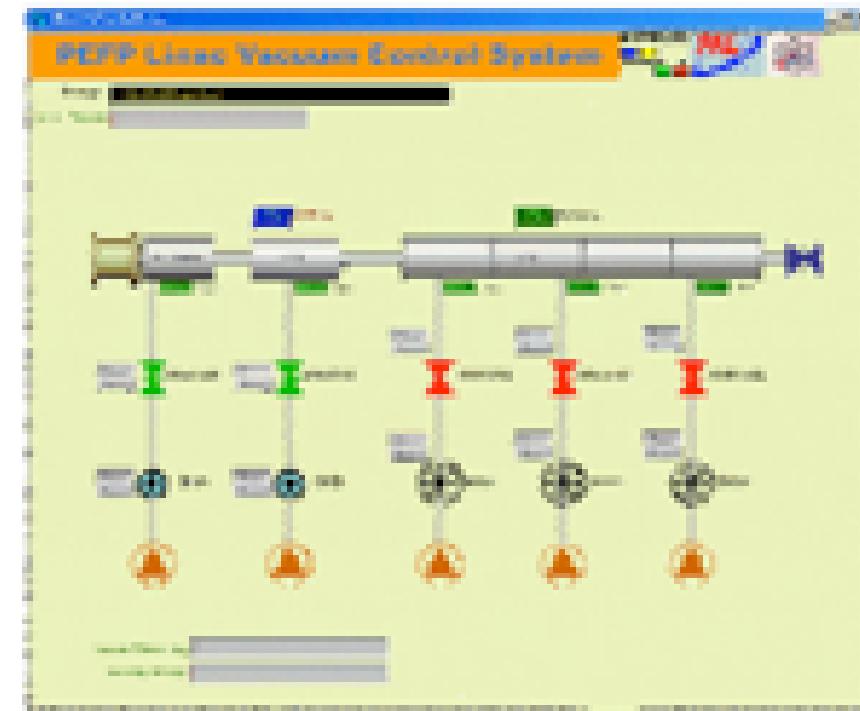
Bob Dalesio
LANL ,USA
May 27 ~31,2003
Seminar room at PAL

Ralph Langer
BESSY ,Berin,Germany
July 28~August 5,2004
EPICS Lab. At PAL

Vacuum Control System



- Windows based PC
- RS422 Interface(63 Ports)
- EPICS base 3.14.1
- MEDM
- Installed and Working at KAERI site



RF Control System

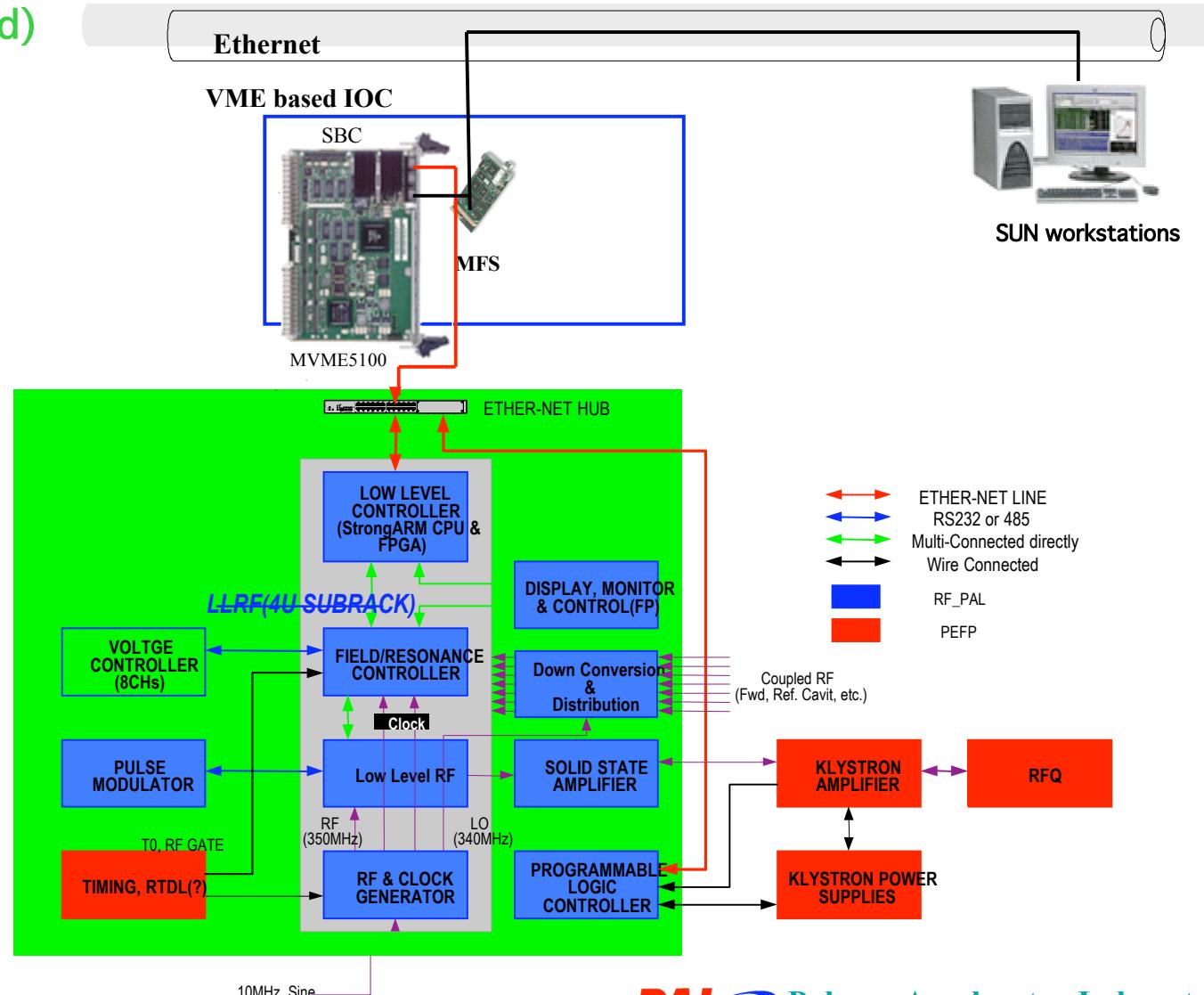
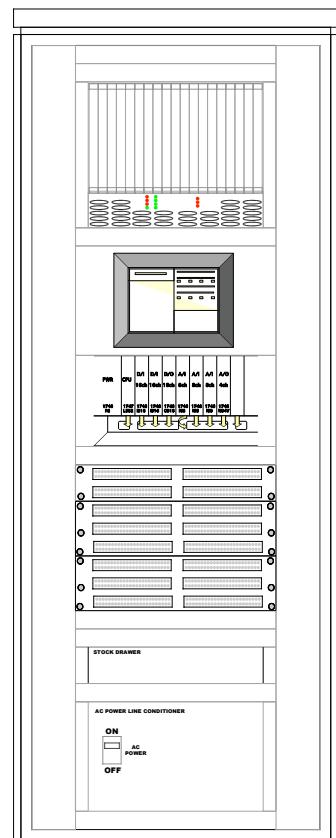


EPICS IOC(Developed)

CPU : MVME5100

VME I/O: MFL32A

EPICS Base 3.13.8



Domestic Products

VMEbus MFL32A



- 16bits ADC, 0~+10V :8Ch
- 16bits DAC, 0~+10V:2Ch
- DIO:32Ch
- 10/100Base T Ethernet
- RS232C ,32bit CPU

Human CC,INC
<http://www.humancc.co.kr>

VME Bus Subrack



- 500W(+5V,-12V,+12V)
- 12 slots, VME64x with P0
- Remote Control(RS422,LAN)

VME Tech ,INC
<http://www.vmetech.co.kr>

Timing Control

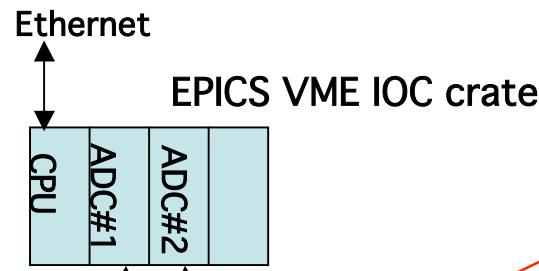
- Event system for timing control has been selected.
- TIMO from SLS made contribution.

-Development Progress

- . Detailed Specification
- . System Configuration Layout
- . Hardware Setup and Software module Test
- . Lab Test



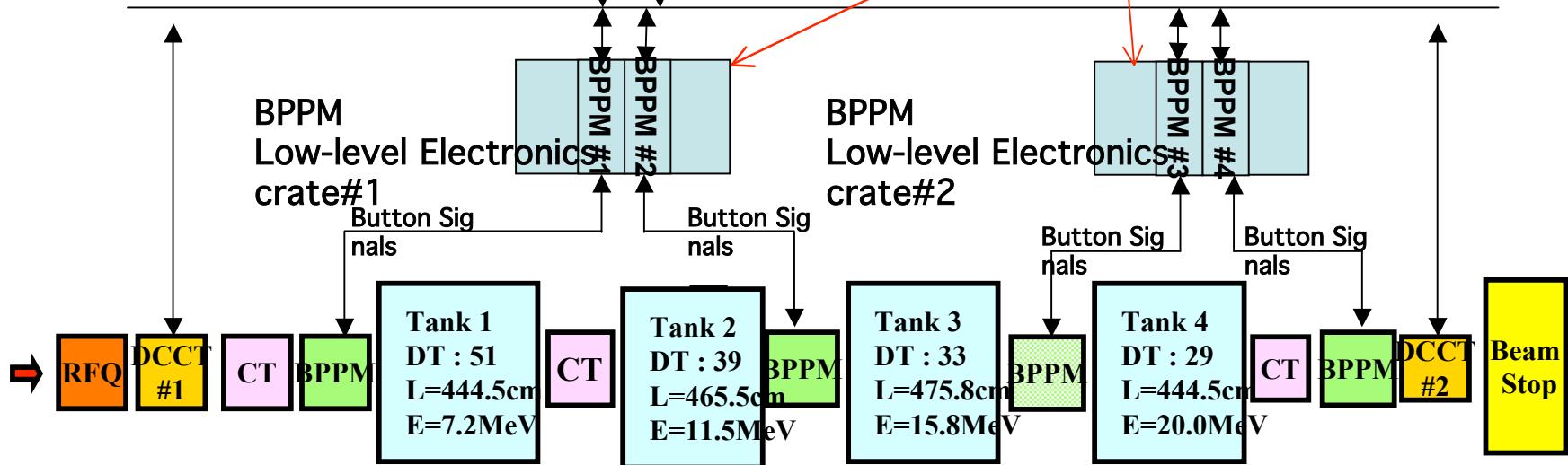
BPM/DCCT Control System(Third Phase)



EPICS IOC(Developing)

CPU : MVME5100
ADC#1 : VTR812/10
ADC#2 : AVME9325-5
EPICS Base 3.13.6

Low Level Electronics(Working) -Bergoz Customized Hardware module

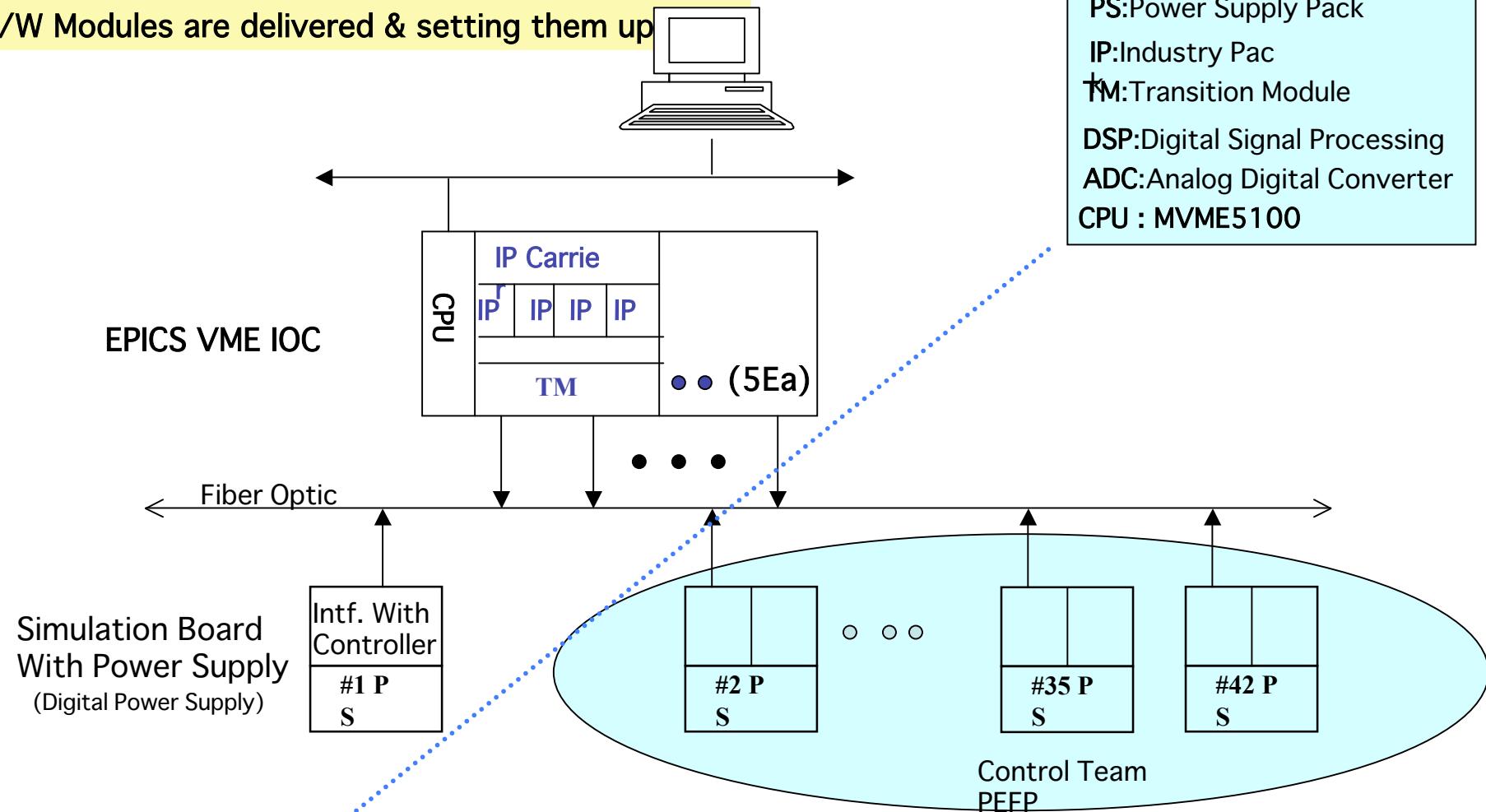


Power Supply Control System for DTL_Q



Selected the SLS Power Supply Type.

H/W Modules are delivered & setting them up

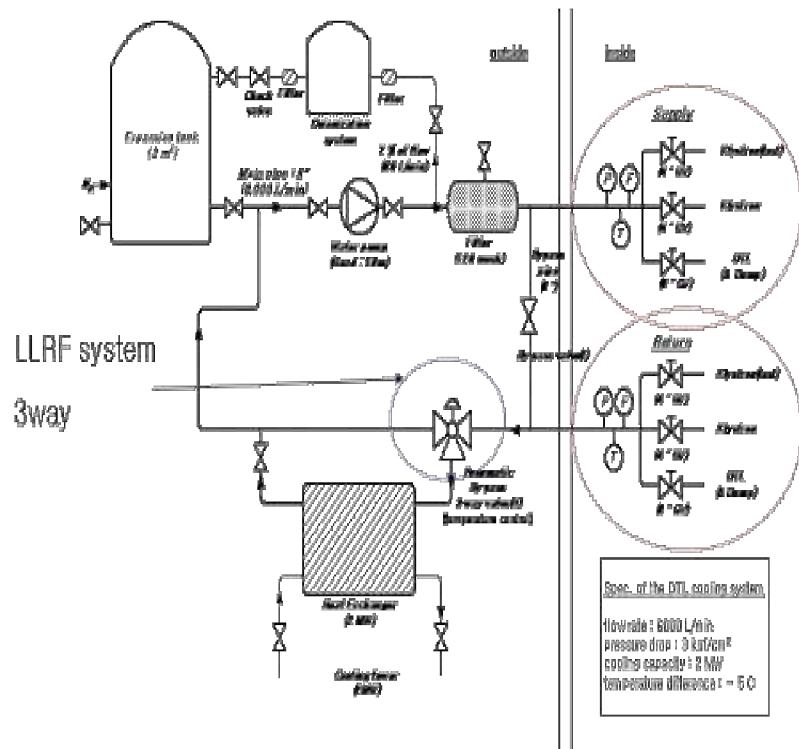


Utility Control(Cooling Water)



Still gathering information for Utility

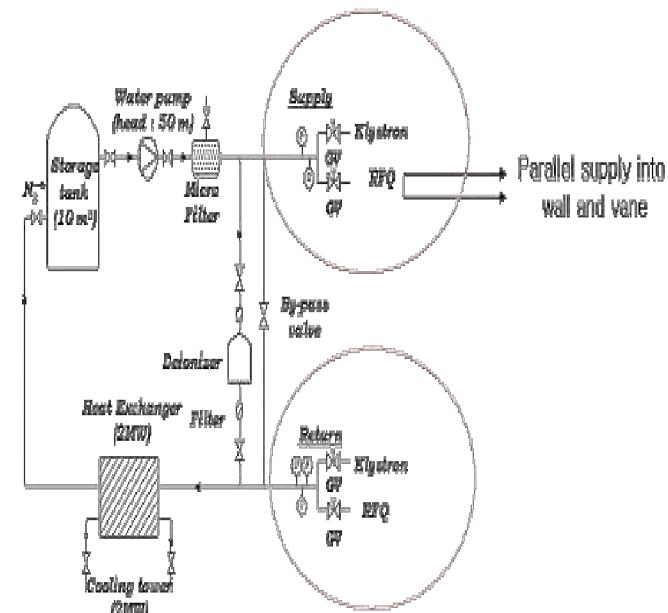
DTL Cooling System



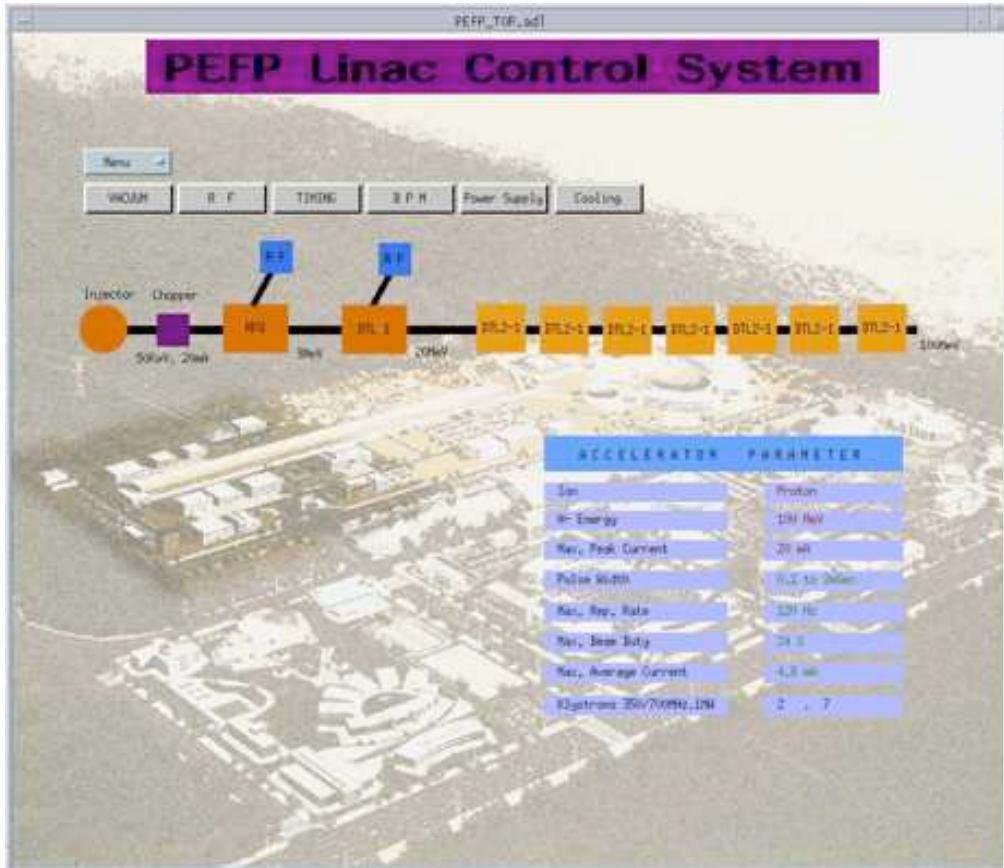
RFQ Cooling System

Specifications

- 3000 l/m, 9 kgf/cm², 2 MW



Main Control Screen for PEFP



LLRF Control Monitor Signal (Analog Input(RF))

1 Proportional Gain Set Value	LLRF_PROP_1K	LLRF1 Output(Feeder Forward)	LLRF1,LLC1,V
0 Proportional Gain Set Value	LLRF_PROP_0K	LLRF2 Output(Feeder Forward)	LLRF2,LLC2,V
1 Integral Gain Set Value	LLRF_INI_1000K	LLRF2 Output(Feeder Forward)	LLRF2,LLC2,V
0 Integral Gain Set Value	LLRF_INI_300K	LLRF2 Output(Feeder Forward)	LLRF2,LLC2,V
Start Feedback Set Value	LLRF_FB_ST_10	Feeder Forward RF Power 2	LLRF1,LLC1,W
Stop Feedback Set Value	LLRF_FB_SF_10	Feeder Reflected RF Power 2	LLRF1,LLC1,W
Start RF Set Value	LLRF_RF_ST_10	Cavity Amplitude 2	LLRF1,LLC1,W
Stop RF Set Value	LLRF_RF_SF_10	Local Oscillator Output Amplitude Level	LLRF1,LLC1,W
Start Beam Set Value	LLRF_BM_ST_10	Drive Amplifier RF Output Power	LLRF1,LLC1,W
Stop Beam Set Value	LLRF_BM_SF_10	Klystron Forward RF Power	LLRF1,LLC1,W
Rotation Set Value	LLRF_ROT_SET_deg	Klystron Reflected RF Power	LLRF1,LLC1,W
RF Stacking Start Set Value	LLRF_SF_ST_10	Circulator Load Reflected RF Power	LLRF1,LLC1,W
RF Stacking Stop Set Value	LLRF_SF_SF_10	1,Feeder Forward RF	LLRF1,LLC1,W
RF Decaging Time Set Value	LLRF_DEC_ST_10	0,Feeder Forward RF	LLRF1,LLC1,W
RF Decaging Stop Set Value	LLRF_DEC_SF_10	1,Reference IF	LLRF1,REF,V
FeedForward Start Set Value	LLRF_FF_ST_10	0,Reference IF	LLRF1,REF,V
FeedForward Stop Set Value	LLRF_FF_SF_10	1,Cavity Field	LLRF1,REF,V
Beam Feedforward Start Set Value	LLRF_FF_BM_ST_10	0,Cavity Field	LLRF1,REF,V
Beam Feedforward Stop Set Value	LLRF_FF_BM_SF_10	Rephaser,Feeder Forward RF	LLRF1,REF,W
Field 1 Set Value	LLRF_FIELD1_1K	Phase,Feeder Forward RF	LLRF1,REF,W
Field 0 Set Value	LLRF_FIELD0_0K	Rephaser,Feeder Reflected RF	LLRF1,REF,W
Field 1 Offset Set Value	LLRF_FIELD1_0K	Phase,Feeder Reflected RF	LLRF1,REF,W
Field 0 Set Value	LLRF_FIELD0_1K	Rephaser,Reference IF	LLRF1,REF,W
Feeder Forward 1 Set Value	LLRF_FF_1_1K	Phase_Reference(IF)	LLRF1,REF,W
Feeder Forward 0 Set Value	LLRF_FF_0_0K	Rephaser,Cavity Field	LLRF1,REF,W
Feeder Forward 1 Offset Set Value	LLRF_FF_1_0K	Phase_Cavity Field	LLRF1,REF,W
Feeder Forward 0 Offset Set Value	LLRF_FF_0_1K	SHRF	LLRF1,REF,W

Summary & Plan



➤ PEFP

- Final Site will be selected by end of this year.

➤ 20Mev Control System for PEFP

IOC Level

- RF (Developed)
- Vacuum (Developed)
- Event System for Timing Control (Developed)
- Beam Monitor (Developing)
- Power Supply (Developing)
- Utility (Still gathering control requirement)

OPI

- MEDM Switch to EDM
- Channel Archiver (From Kay)
- More things..
- EPICS Training to PEFP Physicist, Engineer